Detectors and Background WG

15th IACHEC, April 2023

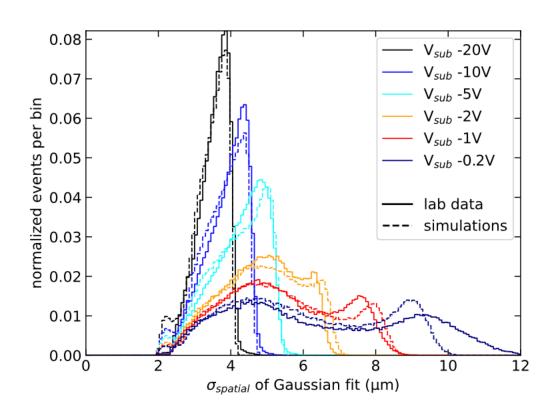
Four talks and short discussion

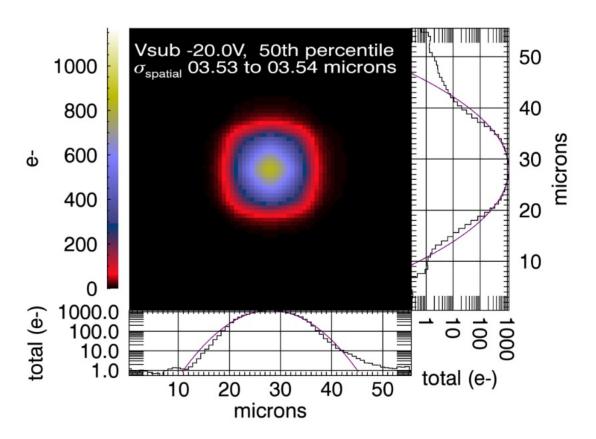
Plus many related talks in plenary sessions

Bev LaMarr – Depletion studies of high thickness to pixel size ratio silicon devices

- Results from two JATIS papers, LaMarr+ 2022, Miller+ 2022, both lab results and simulations
- Future high spatial resolution missions, like Lynx, require "tall small", high aspect ratio pixels, charge sharing between pixels very important
- Measure charge distribution as a function of depth and field strength/device depletion

Bev LaMarr – Depletion studies of high thickness to pixel size ratio silicon devices





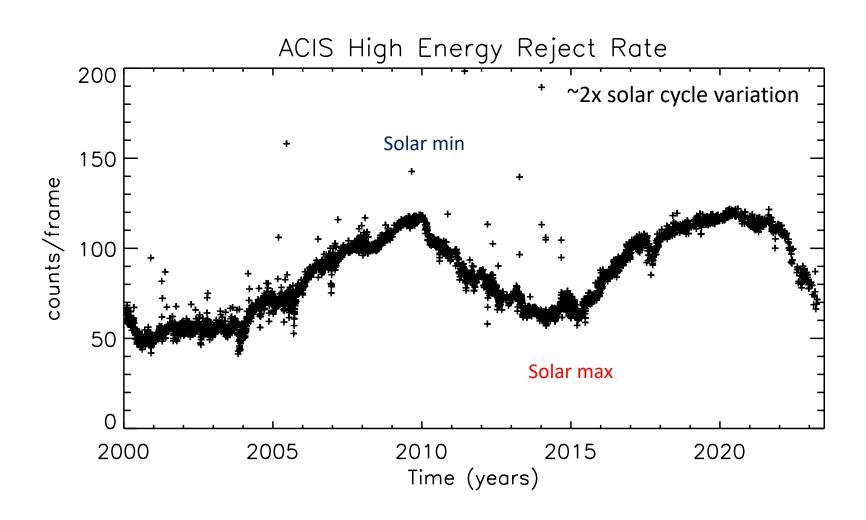
Ivan Valtchanov - XMM EPIC-pn: spatial CTI correction using Cu K α and Mn K α

- Spatial residuals derived using the fluorescent Cu K α line at 8 keV
- Spatial residuals derived using the <u>cal</u> source Mn K α line at 6 keV
 - Both incorporated in EPN_SPATIALCTI_0001.CCF
 - (Both with caveats)
- XMM-SAS task <u>epspatialcti</u> modified to use the new CCF with option SD20mode=yes (set as default)
 - One can choose either to apply the Cu K α or Mn K α with element=CU or element=MN
- Inconclusive analysis of the energy scale compression in 6 to 9 keV
 → not implemented.
- Release note:

https://xmmweb.esac.esa.int/docs/documents/CAL-SRN-0391-1-3.pdf



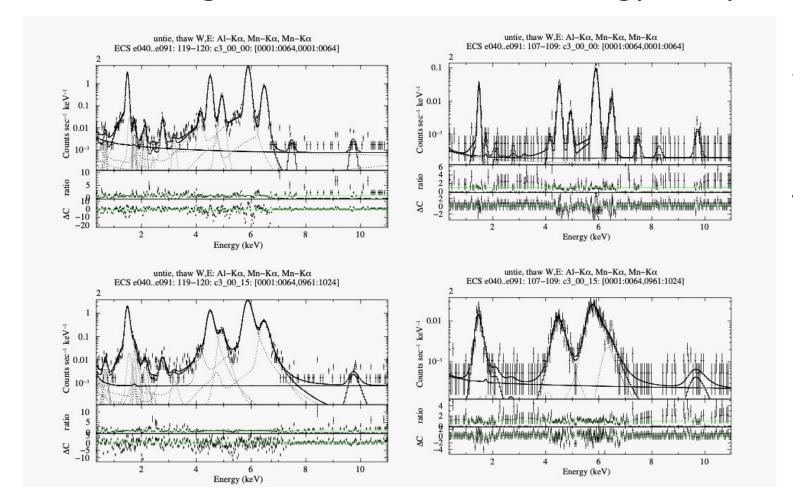
ACIS Background Variability



- Variable on many timescales
- Well correlated with AMS GCR protons
- Future plans
 - Include all ACIS data
 - More timescales
- Unlike LEO, bkg cannot be accurately predicted

Terry Gaetz – T-dependent ACIS response

Calibrating RMF as a function of energy, temperature, and position



WIP

Becoming more Important as intra-observation temperature variation increases

Spectral features in the Si-K edge region

• For Suzaku, gain calibration needed to add discontinuity at the edge

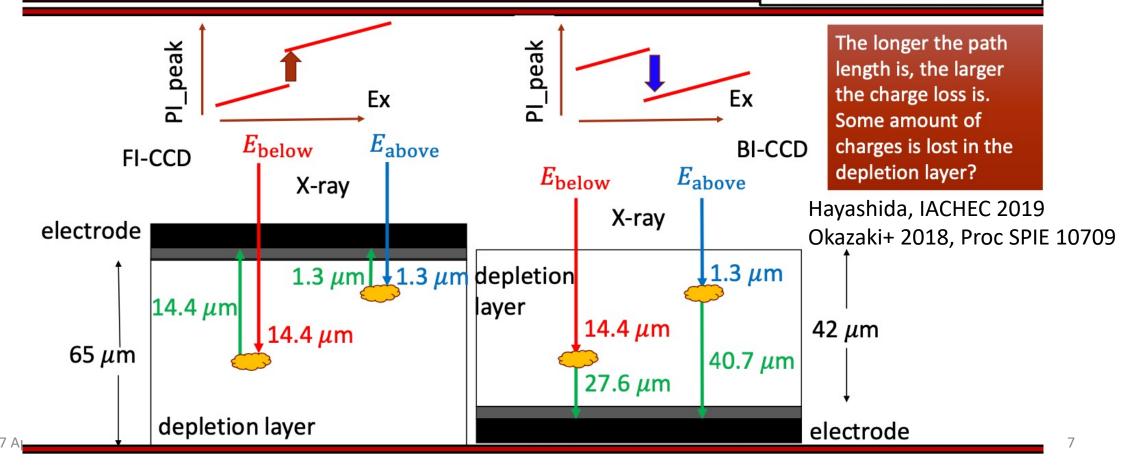


Possible Origin of Jumps

**Si-K edge : 1838.9 eV

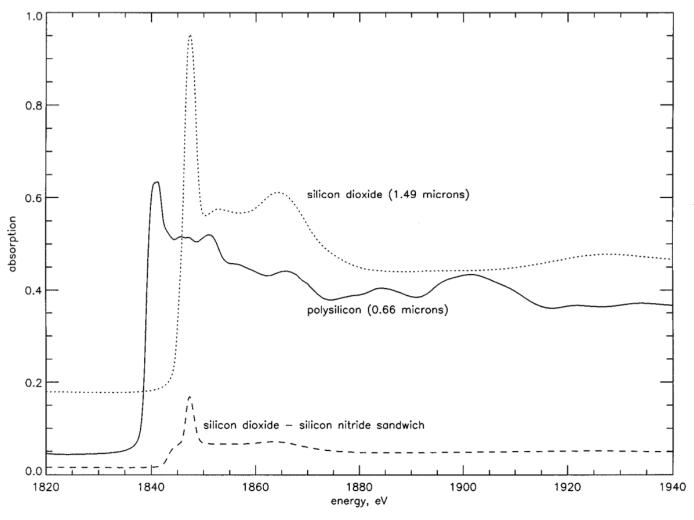
*E*_{below} : 1.838.5 eV

 $E_{
m above}$: 1.839.1 eV



Spectral features in the Si-K edge region

For a thin detector, QE curve may need XAFS at the Si-K edge



Example measurements From ACIS ground cal (Prigozhin+ 1998) Thank you!

Thank you to speakers and participants, see you next year!